

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q87270

Tsunchisa NAMIKI, et al.

Appln. No.: 10/530,357

Group Art Unit: 3742

Confirmation No.: 7770

Examiner: Quang T. VAN

Filed: September 23, 2005

For: METHOD OF FORMING A METAL OXIDE FILM AND MICROWAVE POWER
SOURCE DEVICE USED FOR THE ABOVE METHOD

RESPONSE UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Responsive to the outstanding Office Action of September 28, 2009, once extended from December 28, 2009 to January 28, 2010 by the filing of an appropriate Petition and payment for Extension of Time submitted herewith, please consider Applicants' remarks as follows.

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